

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Konstantin Nikolaevitch KOSHELEV *et al.*

Confirmation No.: 3252

Application No.: 10/664,065

Examiner: Wells, Nikita

Filed: September 17, 2003

Group Art Unit: 2881

For: RADIATION SOURCE, LITHOGRAPHIC APPARATUS AND DEVICE  
MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

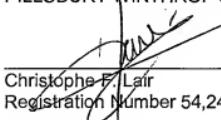
Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO/SB/08a. Unless otherwise indicated herein, one copy of each foreign reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO/SB/08a to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.

Respectfully submitted,

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